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Yun et al.

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(54) OPERATING METHOD OF MEMORY SYSTEM INCLUDING NAND FLASH MEMORY, VARIABLE RESISTANCE MEMORY AND CONTROLLER

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(30) Foreign Application Priority Data

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(51) Int. Cl. G11C 16/10 (2006.01) G11C 11/56 (2006.01) G11C 13/00 (2006.01) G11C 11/16 (2006.01)

(52) U.S. Cl.

(58) Field of Classification Search

See application file for complete search history.

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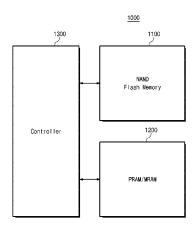
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(57) ABSTRACT

An operating method is for a memory system which includes a NAND flash memory, a resistance variable memory, and a controller controlling the NAND flash memory and the resistance variable memory. The operating method includes receiving data, programming the received data in the NAND flash memory when the received data is at least a super page of data, programming the received data in the resistance variable memory when the received data is not a super page of data, and programming data accumulated in the resistance variable memory in the NAND flash memory when the accumulated data is a super page of data. A super page of data is an entirety of data that is programmable in memory cells connected to a same word line of the NAND flash memory.

20 Claims, 25 Drawing Sheets



US 9,165,657 B2Page 2

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Fig. 1

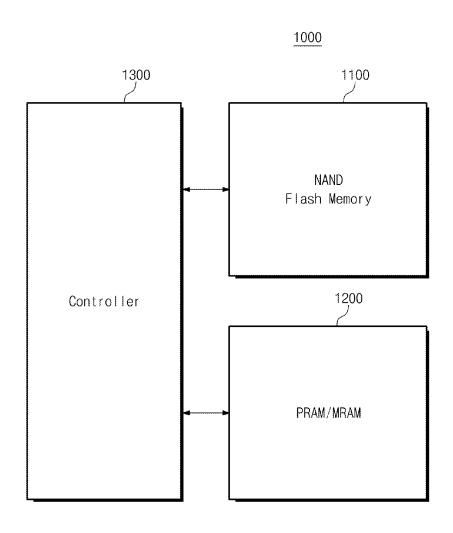


Fig. 2

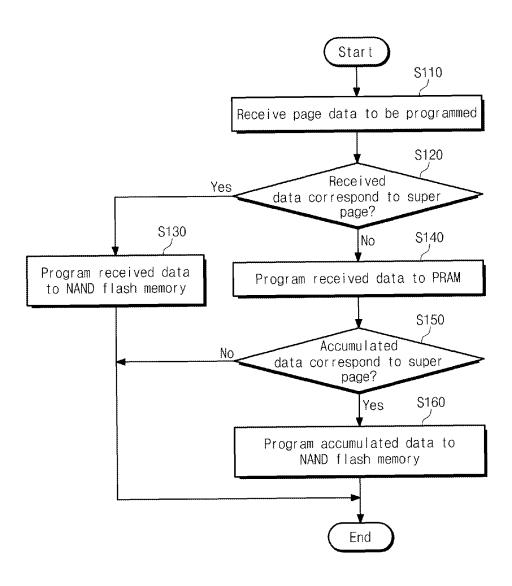


Fig. 3

Page Program Sequence WL5 10 -Super page WL4 7 -Super page 11 -Super page WL3 8 12 -4 -Super page WL2 2 5 WL1 1 3 -Super page 6 -

Fig. 4

•	
	Threshold condition
WL5	
WL4	
WL3	Accumulation of page data corresponding to page program sequence 10 to 12
WL2	Accumulation of page data corresponding to page program sequence 7 to 9
WL 1	Accumulation of page data corresponding to page program sequence 1 to 6

Fig. 5

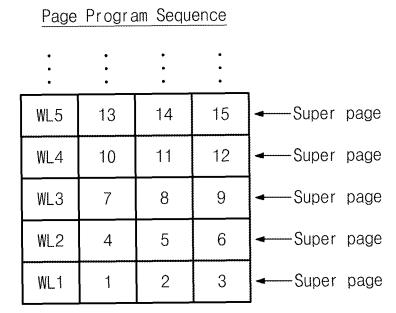


Fig. (

	Threshold condition
ML5	•
WL4	
E7M	Accumulation of page data corresponding to page program sequence 7 to 9
WL2	Accumulation of page data corresponding to page program sequence 4 to 6
ML 1	Accumulation of page data corresponding to page program sequence 1 to 3

Fig. 7

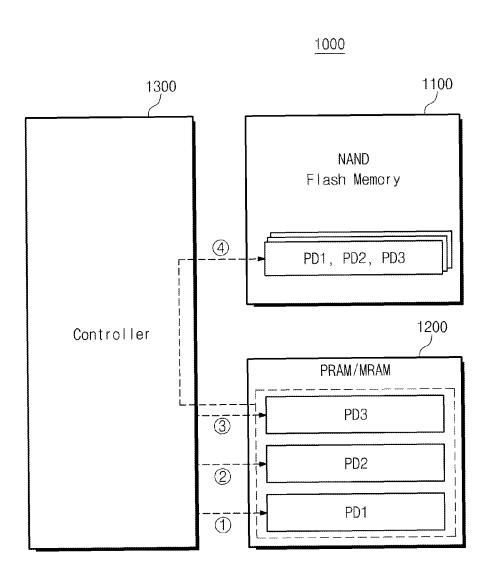


Fig. 8

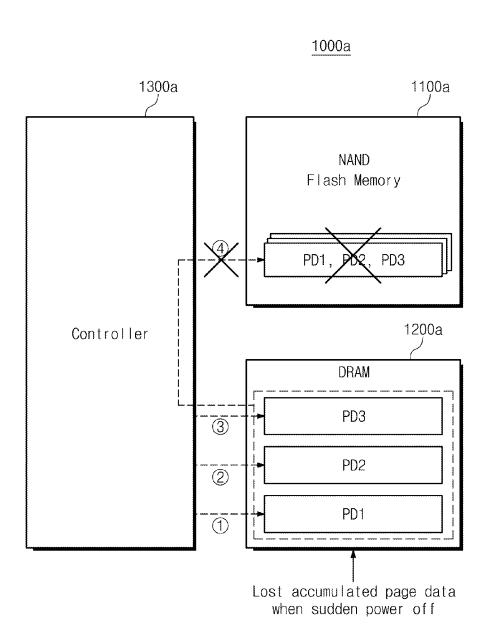


Fig. 9

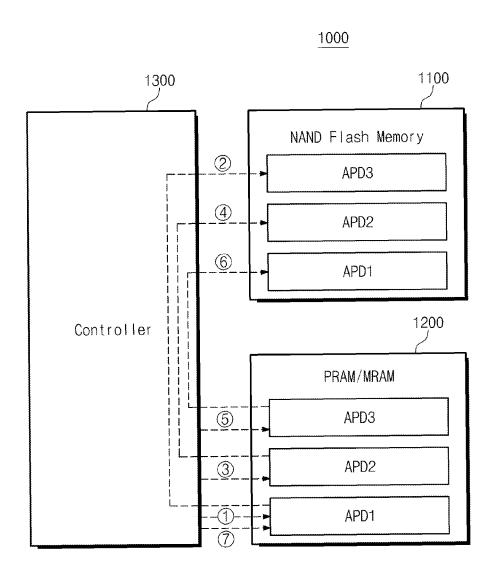


Fig. 10

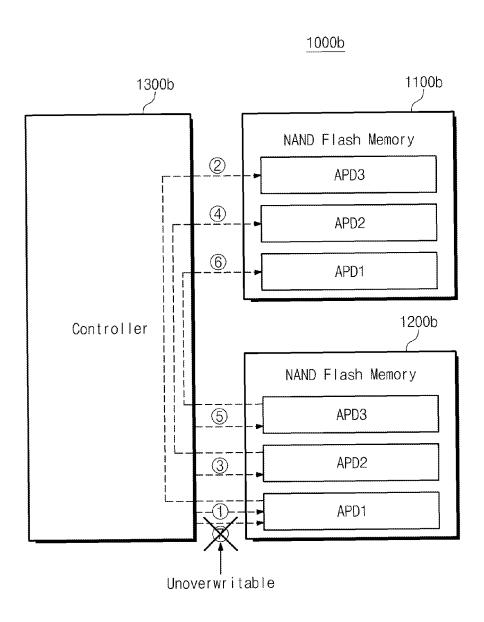


Fig. 11

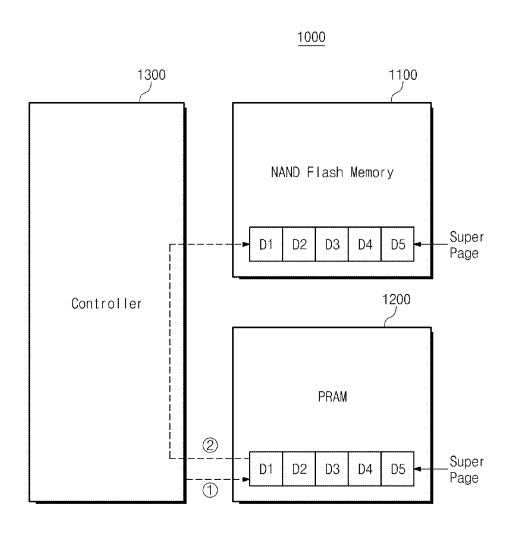


Fig. 12A

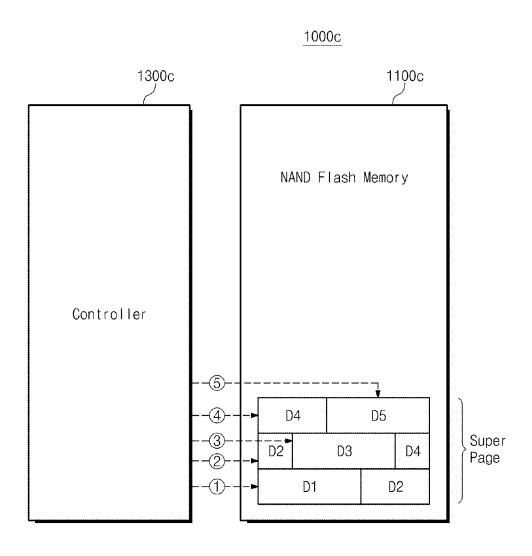


Fig. 12B

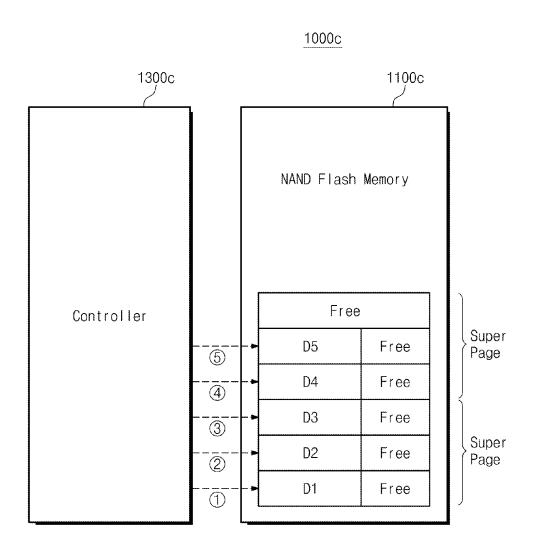


Fig. 13

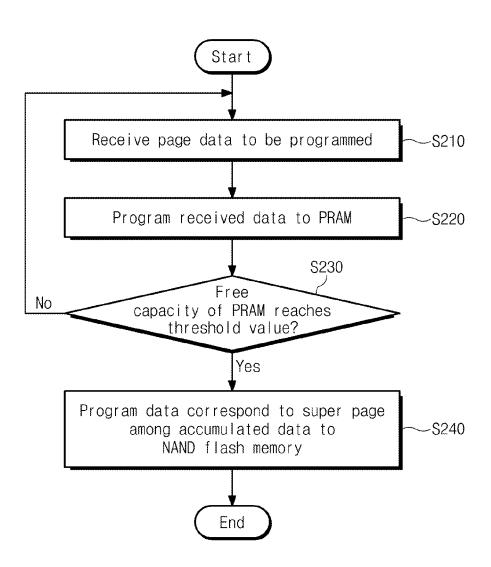


Fig. 14

PRAM/MRAM

APD4

APD4

APD4

APD3

APD3

APD3

APD2

APD1

Fig. 15

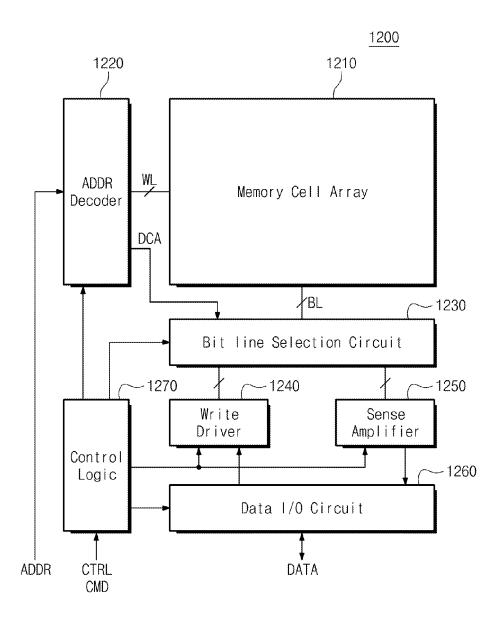


Fig. 16

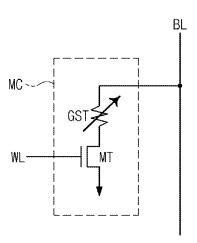


Fig. 17

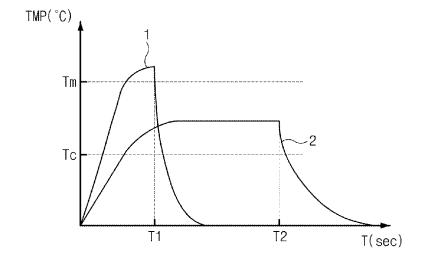


Fig. 18

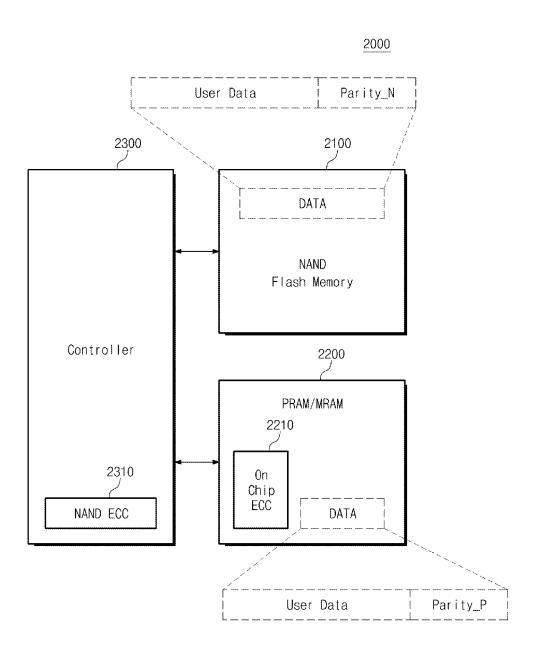


Fig. 19

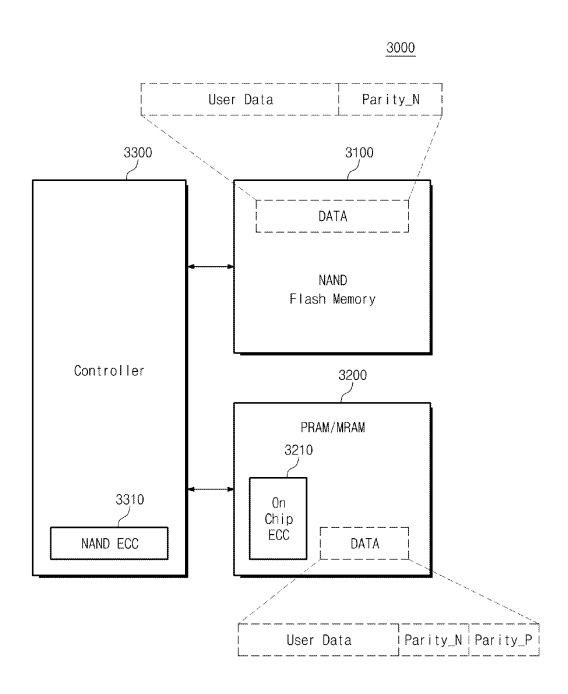


Fig. 20

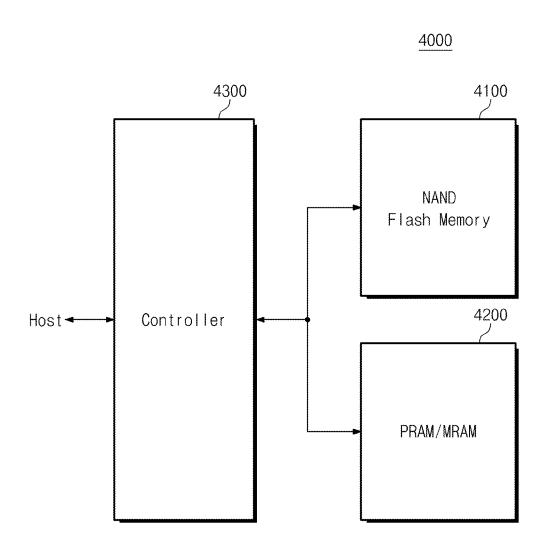


Fig. 21

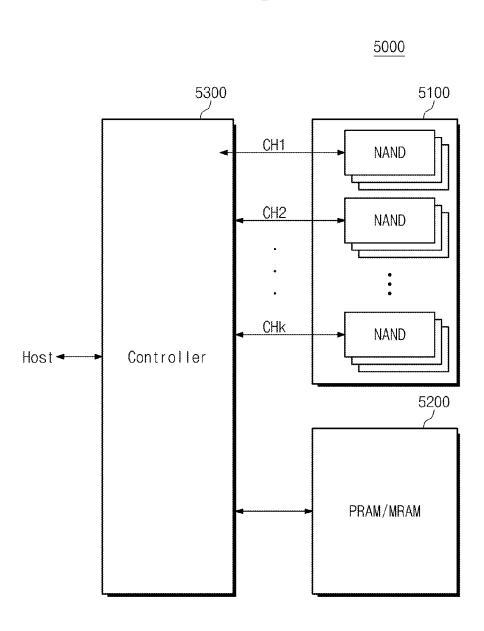


Fig. 22

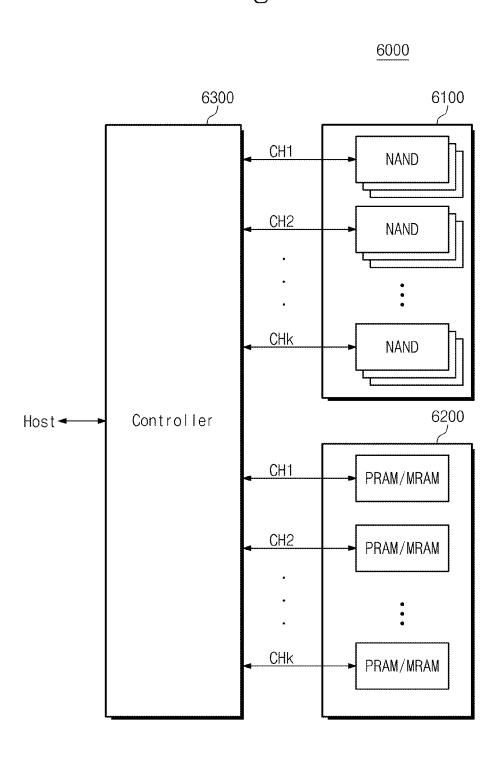


Fig. 23

<u>7000</u>

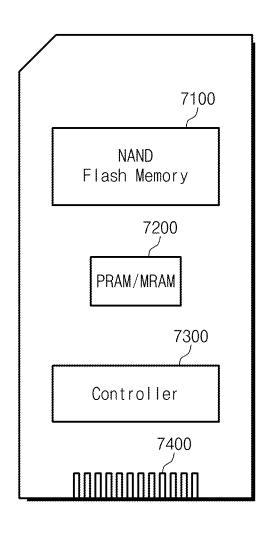


Fig. 24

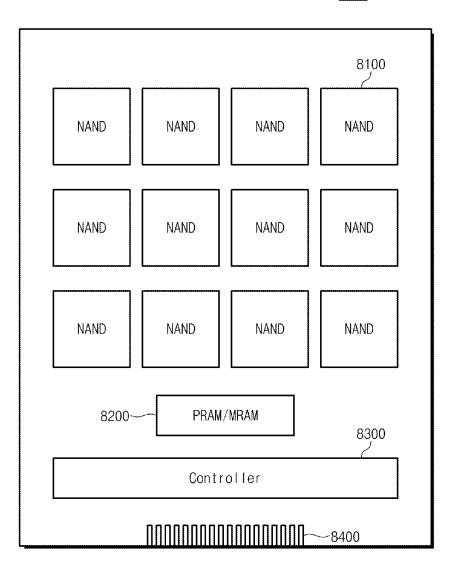
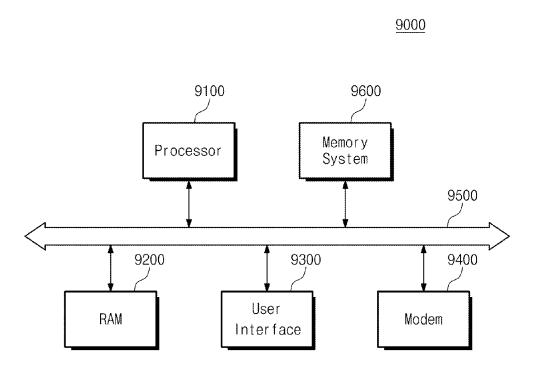


Fig. 25



OPERATING METHOD OF MEMORY SYSTEM INCLUDING NAND FLASH MEMORY, VARIABLE RESISTANCE MEMORY AND CONTROLLER

CROSS-REFERENCE TO RELATED APPLICATIONS

A claim for priority under 35 U.S.C. §119 is made to Korean Patent Application No. 10-2012-0040505 filed Apr. 10 18, 2012, in the Korean Intellectual Property Office, the entire contents of which are hereby incorporated by reference.

BACKGROUND

The inventive concepts described herein generally relate to semiconductor memories, and more particularly, to an operating method of a memory system which includes a NAND flash memory, a variable resistance memory, and a controller.

which is fabricated using semiconductors such as silicon (Si), germanium (Ge), gallium arsenide (GaAs), indium phosphide (InP), and the like. Semiconductor memory devices are generally classified as either volatile memory devices or nonvolatile memory devices.

The volatile memory devices are generally characterized by the loss of stored contents upon a power-off state. Some examples of volatile memory devices include static RAM (SRAM), dynamic RAM (DRAM), synchronous DRAM (SDRAM), and the like. In contrast, nonvolatile memory 30 devices are generally characterized by the retention of stored contents when power is turned off or otherwise disconnected. Examples of nonvolatile memory devices include read only memory (ROM), programmable ROM (PROM), electrically programmable ROM (EPROM), electrically erasable and 35 concept. programmable ROM (EEPROM), flash memory device, phase-change RAM (PRAM), magnetic RAM (MRAM), resistive RAM (RRAM), ferroelectric RAM (FRAM), and the like. Among these, flash memory is typically configured memory.

SUMMARY

Example embodiments of the inventive concept provide an 45 operating method of a memory system, where the memory system includes a NAND flash memory, a resistance variable memory, and a controller controlling the NAND flash memory and the resistance variable memory. The method includes receiving data, programming the received data in the 50 NAND flash memory when the received data is at least a super page of data, programming the received data in the resistance variable memory when the received data is not a super page of data, and programming data accumulated in the resistance variable memory in the NAND flash when the data accumu- 55 lated in the resistance variable memory is a super page of data. A super page of data is an entirety of data that is programmable in memory cells connected to a same word line of the NAND flash memory.

Other embodiments of the inventive concept provide an 60 operating method of a memory systems, where the memory system includes a NAND flash memory, a resistance variable memory, and a controller controlling the NAND flash memory and the resistance variable memory, where the NAND flash memory is configured to store N bits of data per 65 memory cell, and N pages of data per word line of each memory block, and where N is two or more. The method

2

includes receiving data, programming the received data in the NAND flash memory when the received data is at least N pages of data, programming the received data in the resistance variable memory when the received data is less than N pages of data, and programming accumulated data programmed in the resistance variable memory in the NAND flash memory when the accumulated data is at least N pages of data.

Still other example embodiments of the inventive concept provide an operating method of a memory system, where the memory system includes a NAND flash memory, a resistance variable memory, and a controller controlling the NAND flash memory and the resistance variable memory. The method includes receiving data, programming the received data in the resistance variable memory, and programming a super page of data among data accumulated in the resistance variable memory in NAND flash memory when a free capacity of the resistance variable memory reaches a threshold value. A super page of data is an entirety of data that is A semiconductor memory device is a data storage device 20 programmable in memory cells connected to a same word line of the NAND flash memory.

BRIEF DESCRIPTION OF THE FIGURES

The above and other objects and features will become apparent from the description that follows with reference to the accompanying figures, wherein like reference numerals refer to like parts throughout the various figures unless otherwise specified.

FIG. 1 is a block diagram schematically illustrating a memory system according to an embodiment of the inventive

FIG. 2 is a flowchart illustrating an operating method of a memory system according to an embodiment of the inventive

FIG. 3 is a diagram illustrating a program sequence of a NAND flash memory according to an embodiment of the inventive concept.

FIG. 4 is a diagram illustrating an operating method of FIG. as either NOR type flash memory or a NAND type flash 40 2 executed according to the program sequence shown in FIG.

> FIG. 5 is a diagram illustrating a program sequence of a NAND flash memory according to another embodiment of the inventive concept.

FIG. 6 is a diagram illustrating an operating method of FIG. 2 executed according to the program sequence shown in FIG.

FIG. 7 is a diagram illustrating an operating method of FIG. 2 executed in a memory system according to an embodiment of the inventive concept.

FIG. 8 is a diagram illustrating an operating method of FIG. 2 executed in a memory system including a DRAM instead of a phase change memory according to an embodiment of the inventive concept.

FIG. 9 is a diagram illustrating another example of an operating method of FIG. 2 executed in a memory system according to an embodiment of the inventive concept.

FIG. 10 is a diagram illustrating an operating method of FIG. 2 executed in a memory system including a NAND flash memory instead of a phase change memory according to an embodiment of the inventive concept.

FIG. 11 is a diagram illustrating still another example of an operating method of FIG. 2 executed in a memory system according to an embodiment of the inventive concept.

FIG. 12A is a diagram illustrating an operating method of FIG. 2 executed in a memory system having a NAND flash memory.

3

FIG. 12B is a diagram illustrating another example of operating method in FIG. 2 executed in a memory system having a NAND flash memory.

FIG. 13 is a flowchart illustrating an operating method of a memory system according to another embodiment of the 5 inventive concept.

FIG. 14 is a diagram illustrating an operating method of FIG. 13 executed in a memory system according to embodiments of the inventive concept.

FIG. 15 is a block diagram schematically illustrating a phase change memory according to an embodiment of the inventive concept.

FIG. 16 is a diagram illustrating a memory cell of a phase change memory.

FIG. 17 is a graph illustrating characteristics of a phase change material.

FIG. 18 is a block diagram schematically illustrating a memory system according to another embodiment of the inventive concept.

FIG. 19 is a block diagram schematically illustrating a memory system according to still another embodiment of the inventive concept.

FIG. 20 is a block diagram schematically illustrating a memory system according to still another embodiment of the 25 inventive concept.

FIG. 21 is a block diagram schematically illustrating a memory system according to still another embodiment of the inventive concept.

FIG. 22 is a block diagram schematically illustrating a 30 memory system according to still another embodiment of the inventive concept.

FIG. 23 is a diagram illustrating a memory card according to an embodiment of the inventive concept.

FIG. 24 is a diagram illustrating a solid state drive according to an embodiment of the inventive concept.

FIG. 25 is a block diagram illustrating a computing system according to an embodiment of the inventive concept.

DETAILED DESCRIPTION

Embodiments will be described in detail with reference to the accompanying drawings. The inventive concept, however, may be embodied in various different forms, and should not be construed as being limited only to the illustrated embodi- 45 ments. Rather, these embodiments are provided as examples so that this disclosure will be thorough and complete, and will fully convey the concept of the inventive concept to those skilled in the art. Accordingly, known processes, elements, and techniques are not described with respect to some of the 50 embodiments of the inventive concept. Unless otherwise noted, like reference numerals denote like elements throughout the attached drawings and written description, and thus descriptions will not be repeated. In the drawings, the sizes and relative sizes of layers and regions may be exaggerated 55 memory system according to an embodiment of the inventive for clarity.

It will be understood that, although the terms "first", "second", "third", etc., may be used herein to describe various elements, components, regions, layers and/or sections, these elements, components, regions, layers and/or sections should 60 not be limited by these terms. These terms are only used to distinguish one element, component, region, layer or section from another region, layer or section. Thus, a first element, component, region, layer or section discussed below could be termed a second element, component, region, layer or section 65 without departing from the teachings of the inventive con-

Spatially relative terms, such as "beneath", "below", "lower", "under", "above", "upper" and the like, may be used herein for ease of description to describe one element or feature's relationship to another element(s) or feature(s) as illustrated in the figures. It will be understood that the spatially relative terms are intended to encompass different orientations of the device in use or operation in addition to the orientation depicted in the figures. For example, if the device in the figures is turned over, elements described as "below" or "beneath" or "under" other elements or features would then be oriented "above" the other elements or features. Thus, the exemplary terms "below" and "under" can encompass both an orientation of above and below. The device may be otherwise oriented (rotated 90 degrees or at other orientations) and the spatially relative descriptors used herein interpreted accordingly. In addition, it will also be understood that when a layer is referred to as being "between" two layers, it can be the only layer between the two layers, or one or more intervening layers may also be present.

The terminology used herein is for the purpose of describing particular embodiments only and is not intended to be limiting of the inventive concept. As used herein, the singular forms "a", "an" and "the" are intended to include the plural forms as well, unless the context clearly indicates otherwise. It will be further understood that the terms "comprises" and/ or "comprising," when used in this specification, specify the presence of stated features, integers, steps, operations, elements, and/or components, but do not preclude the presence or addition of one or more other features, integers, steps, operations, elements, components, and/or groups thereof. As used herein, the term "and/or" includes any and all combinations of one or more of the associated listed items. Also, the term "exemplary" is intended to refer to an example or illustration.

It will be understood that when an element or layer is referred to as being "on", "connected to", "coupled to", or "adjacent to" another element or layer, it can be directly on, connected, coupled, or adjacent to the other element or layer, or intervening elements or layers may be present. In contrast, when an element is referred to as being "directly on," "directly connected to", "directly coupled to", or "immediately adjacent to" another element or layer, there are no intervening elements or layers present.

Unless otherwise defined, all terms (including technical and scientific terms) used herein have the same meaning as commonly understood by one of ordinary skill in the art to which this inventive concept belongs. It will be further understood that terms, such as those defined in commonly used dictionaries, should be interpreted as having a meaning that is consistent with their meaning in the context of the relevant art and/or the present specification and will not be interpreted in an idealized or overly formal sense unless expressly so defined herein.

FIG. 1 is a block diagram schematically illustrating a concept. Referring to FIG. 1, a memory system 1000 may include a NAND flash memory 1100, a phase change memory 1200, and a controller 1300.

The NAND flash memory 1100 may perform program, read, and erase operations under control of the controller 1300. The NAND flash memory 1100 may be configured to store multi-bit data in each memory cell thereof.

Generally, the operational characteristic of the NAND flash memory 1100 differ from those of a random access memory (RAM). For example, the NAND flash memory 1100 may have an erase-before-write characteristic, i.e., the. memory cells are erased before being written or programmed.

Also, a program unit and/or read unit of the NAND flash memory 1100 may be of a different unit memory size than an erase unit of the NAND flash memory 1100. Here, a "unit" denotes memory cells which may be programmed, read or erased at the same time.

For example, a program unit and/or read unit of the NAND flash memory 1100 may be a page of memory. A page may be formed of memory cells connected with a same word line of the NAND flash memory 1100. In the event that memory cells of the NAND flash memory 1100 are arranged in three dimensions, memory cells arranged in two dimensions along rows and columns may be commonly connected to a same word line. In this case, a page constituting a program or read unit may be formed of a row of memory cells or a column of memory cells from among the two dimensionally arranged 15 memory cells commonly connected to the same word line.

An erase unit of the NAND flash memory 1100 may be a memory block. The memory block may include memory cells connected to a plurality of word lines. Thus, a size of the memory block which constitutes an erase unit may be larger 20 than the size of a page constituting a program unit and/or read unit

The phase change memory 1200 may perform program, read, and erase operations under control of the controller 1300. The phase change memory 1200 may be configured to 25 store a single bit or multiple bits per memory cell. The phase change memory 1200 may be a random access memory, and may not have an erase-before-write characteristic. Instead, the phase change memory 1200 may support an overwrite function. Before memory cells connected with a word line are 30 erased, the phase change memory 1200 may program the memory cells several times. That is, the phase change memory 1200 may provide a plural NOP (number of program).

The phase change memory 1200 may be a phase change 35 RAM (PRAM) including memory cells each having a crystal state or an amorphous state. However, this is just an example, and other types of resistance variable memories may be utilized instead, such as a magnetic RAM (MRAM) including memory cells having a parallel magnetic state or an antiparallel magnetic state.

The controller 1300 may be configured to control the NAND flash memory 1100 and the phase change memory 1200. A physical address system of the NAND flash memory 1100 may be different from a logical address system of a host 45 due at least in part to the above-described erase-before-write characteristic of the NAND flash memory 1100. The controller 1300 may interconvert the logical address system of the host and the physical address system of the NAND flash memory 1100.

The controller 1300 may control an erase operation of the NAND flash memory 1100. The controller 1300 may process data, established to be erased at a host, as invalid data. In an idle state, the controller 1300 may make a programmable memory block by erasing a memory block in which invalid 55 data is stored.

The controller 1300 may use the NAND flash memory 1100 as a mass storage device and the phase change memory 1200 as a buffer memory. As described above, the phase change memory 1200 may be accessed randomly and overwritten. The controller 1300 may temporarily store data received from a host at the phase change memory 1200, and may copy data stored at the phase change memory 1200 to be stored at the NAND flash memory 1100.

FIG. 2 is a flowchart illustrating an operating method of a 65 memory system according to an embodiment of the inventive concept. Referring to FIGS. 1 and 2, in operation S110, a

6

memory system 1000 may receive data to be programmed. For example, a controller 1300 may receive data to be programmed from an external host.

In operation S120, a judgment is made as whether the input data corresponds to a super page. This judgment may be made by the controller 1300. The super page constitutes at least a quantity of data to be programmed in all of the programmable memory cells connected with a same word line. The super page can include two or more bits to be programmed at each of memory cells connected with the same word line. Also, the super page may further include at least one bit to be programmed at each of memory cells connected with a word line adjacent to the word line.

When the input data corresponds to the super page, in operation S130, the input data may be programmed at a NAND flash memory 1100. The controller 1300 may control the NAND flash memory 1100 to program the input data.

When the input data does not correspond to the super page, for example, when the input data is smaller in size than the super page, in operation S140, the input data may be programmed at a phase change memory 1200. The controller 1300 may control the phase change memory 1200 to program the input data.

For example, when a part of the input data corresponds to the super page and the rest thereof does not correspond to the super page, the controller 1300 data, corresponding to the super page, from among the input data at the NAND flash memory 1100 and the rest thereof at the phase change memory 1200.

In operation S150, whether data accumulated at the phase change memory 1200 corresponds to the super page may be judged. The controller 1300 may judge whether data accumulated at the phase change memory 1200 corresponds to the super page.

When the data accumulated at the phase change memory 1200 corresponds to the super page, in operation S160, the accumulated data may be programmed at the NAND flash memory 1100. The controller 1300 may control the NAND flash memory 1100 and the phase change memory 1200 such that data, corresponding to the super page, from among data accumulated at the phase change memory 1200 is programmed at the NAND flash memory 1100.

FIG. 3 is a diagram illustrating a program sequence of a NAND flash memory according to an embodiment of the inventive concept. In FIG. 3, there is exemplarily illustrated an example that three bits are stored at a memory cell. However, the inventive concept is not limited thereto.

Referring to FIGS. 1 to 3, a first program operation "1" may be performed with respect to a first word line WL1 of a NAND flash memory 1100. For example, least significant bits may be programmed at memory cells connected with the first word line WL1.

A second program operation "2" may be performed with respect to a second word line WL2 adjacent to the first word line WL1. Least significant bits may be programmed at memory cells connected with the second word line WL2.

A third program operation "3" may be performed with respect to the first word line WL1. Central significant bits may be programmed at memory cells connected with the first word line WL1.

A fourth program operation "4" may be performed with respect to a third word line WL3 adjacent to the second word line WL2. Least significant bits may be programmed at memory cells connected with the third word line WL3.

A fifth program operation "5" may be performed with respect to the second word line WL2. Central significant bits may be programmed at memory cells connected with the second word line WL2.

A sixth program operation "6" may be performed with 5 respect to the first word line WL1. Most significant bits may be programmed at memory cells connected with the first word line WL1.

A seventh program operation "7" may be performed with respect to a fourth word line WL4 adjacent to the third word line WL3. Least significant bits may be programmed at memory cells connected with the fourth word line WL4.

An eighth program operation "8" may be performed with respect to the third word line WL3. Central significant bits may be programmed at memory cells connected with the third 15 word line WL3.

A ninth program operation "9" may be performed with respect to the second word line WL2. Most significant bits may be programmed at memory cells connected with the second word line WL2. In FIG.3, "10", "11" and "12" denote 20 tenth, eleventh and twelfth program operations, respectively.

With the above description, a program operation may be alternately performed at adjacent word lines WL1 to WL5. Before central significant bits are programmed at memory cells connected to the first word line WL1, least significant 25 bits may be programmed at memory cells connected with a second word line WL2 adjacent to the first word line WL1. Before most significant bits are programmed at memory cells connected to the first word line WL1, central significant bits may be programmed at memory cells connected with the 30 second word line WL2 adjacent to the first word line WL1.

In example embodiments, data needed to complete programming of memory cells connected with a word line (or, a program or read unit of memory cells) may form a super page. When each of memory cells connected with a word line stores 35 three bits, the super page may include 3-bit data stored at each of memory cells connected with the word line. Until programming of memory cells connected with a word line is completed, the super page may further include data to be proadjacent to the word line.

FIG. 4 is a diagram illustrating an operating method shown in FIG. 2 executed according to a program sequence shown in FIG. 3. Referring to FIGS. 1 to 4, the condition that data accumulated at a phase change memory 1200 is transferred to 45 a NAND flash memory 1100 may be established according to a super page.

Three pages of data (program sequence 1, 3, 6) to be programmed at memory cells of a first word line WL1, two pages of data (program sequence 2 and 5) to be programmed 50 at memory cells of a second word line WL2, and one page of data (program sequence 4) to be programmed at memory cells of a third word line WL3 may be required to complete programming of memory cells connected with the first word line WL1. When data needed to complete programming of 55 memory cells connected with the first word line WL1 is accumulated, the accumulated data may be transferred to the NAND flash memory 1100. This threshold condition is referred to in FIG. 4 as "Accumulation of the page corresponding to page program sequence 1 to 6."

If programming of the memory cells connected with the first word line WL1 is completed, least significant bits and central significant bits may be programmed at memory cells connected with the second word line WL2. At this state, one page of data (program sequence 7) to be programmed at 65 memory cells of a fourth word line WL4, one page of data (program sequence 7) to be programmed at memory cells of

the third word line WL3, and one page of data (program sequence 9) to be programmed at memory cells of the second word line WL2 may be required to complete programming of memory cells connected with the second word line WL2. When data needed to complete programming of memory cells connected with the second word line WL2 is accumulated, the accumulated data may be transferred to the NAND flash memory 1100. This threshold condition is referred to in FIG. 4 as "Accumulation of page data corresponding to page program sequence 7 to 9."

When programming of the memory cells connected with the second word line WL2 is completed, least significant bits and central significant bits may be programmed at memory cells connected with the third word line WL3. At this state, one page of data (program sequence 10) to be programmed at memory cells of a fifth word line WL5, one page of data (program sequence 11) to be programmed at memory cells of the fourth word line WL4, and one page of data (program sequence 12) to be programmed at memory cells of the third word line WL3 may be required to complete programming of memory cells connected with the third word line WL3. When data needed to complete programming of memory cells connected with the third word line WL3 is accumulated, the accumulated data may be transferred to the NAND flash memory 1100. This threshold condition is referred to in FIG. 4 as "Accumulation of page data corresponding to page program sequence 10 to 12."

In example embodiments, a super page may be used as the condition that data input from an external device is directly programmed at the NAND flash memory 1100, not programmed at the phase change memory 1200. When data input from an external device corresponds to a super page, the input data may be directly programmed at the NAND flash memory 1100. When data input from an external device does not correspond to a super page, for example, when data input from an external device is smaller in size than a super page, the input data may be programmed at the phase change memory 1200.

FIG. 5 is a diagram illustrating a program sequence of a grammed at memory cells connected with a word line 40 NAND flash memory according to another embodiment of the inventive concept. In FIG. 5, there is exemplarily illustrated an example that three bits are stored in a memory cell in a NAND flash memory 1100. However, the inventive concept is not limited thereto. Also, similar to FIG. 3, the numbers 1, 2, 3, 4, 5, 6, 7, 8, 9, 10, 11, 12, 13, 14 and 15 denote the first through fifteen program operations of the program sequence, respectively.

> Referring to FIGS. 1, 2, and 5, first to third program operations may be performed with respect to a first word line WL1 of the NAND flash memory 1100. Fourth to sixth program operations may be performed with respect to a second word line WL2 of the NAND flash memory 1100. Seventh to ninth program operations may be performed with respect to a third word line WL3 of the NAND flash memory 1100. 10th to 12th program operations may be performed with respect to a fourth word line WL4 of the NAND flash memory 1100. 13th to 15th program operations may be performed with respect to a fifth word line WL5 of the NAND flash memory 1100.

In FIG. 5, a program operation may be performed by a 60 word line unit. After memory cells connected with a word line, memory cells connected with a word line adjacent to the word line may be programmed. That is, page data programmed at memory cells connected with a word line (or, memory cells belonging to a program or read unit) may form a super page. For example, in the case of an MLC NAND flash memory configured to store N bits of data per memory cell, and N pages of data per word line of each memory block, a

super page is constituted by N pages of data. Here, N is two or more. Thus, in this case, when three bits are stored in each memory cell, three pages of data form a super page.

FIG. 6 is a diagram illustrating an operating method in FIG. 2 executed according to a program sequence in FIG. 5. Referring to FIGS. 1, 2, 5, and 6, a super page may be used to establish a condition that data accumulated at a phase change memory 1200 is transferred to the NAND flash memory 1100.

Three pages of data (program sequence 1, 2, and 3) to be programmed t memory cells connected with a first word line WL1 may be required to complete rogramming of memory cells connected with the first word line WL1. When three ages of data (program sequence 1, 2, and 3) to be programmed at memory cells nnected with the first word line WL1 are accumulated at the phase change memory 200, the accumulated data may be sent to the NAND flash memory 1100. This threshold condition is referred to in FIG. 6 as "Accumulation of page data corresponding to page program sequence 1 to 3."

Three pages of data (program sequence **4**, **5**, and **6**) to be programmed t memory cells connected with a second word line WL2 may be required to complete programming of memory cells connected with the second word line WL2. When three pages of data (program sequence **4**, **5**, and **6**) to be programmed at memory cells connected with the second word line WL2 are accumulated at the phase change memory **1200**, the accumulated data may be sent to the NAND flash memory **1100**. This thres hold condition is referred to in FIG. **6** as "Accumulation of page data corresponding to page program sequence **4** to **6**."

Three pages of data (program sequence 7, 8, and 9) to be programmed at memory cells connected with a third word line WL3 may be required to complete programming of memory cells connected with the third word line WL3. When three pages of data (program sequence 7, 8, and 9) to be 35 programmed at memory cells connected with the third word line WL3 are accumulated at the phase change memory 1200, the accumulated data may be sent to the NAND flash memory 1100. This threshold condition is referred to in FIG. 6 as "Accumulation of page data corresponding to page program 40 sequence 7 to 9."

As described with reference to FIGS. 3 to 6, when data (data corresponding to a super page) required to complete programming of memory cells connected with a word line is received from an external device, the received data may be 45 directly programmed at the NAND flash memory 1100. On the other hand, when data smaller in size than the super page is received, the received data may be programmed at the phase change memory 1200. Also, when data accumulated at the phase change memory 1200 corresponds to the super page, 50 the accumulated data may be transferred to the NAND flash memory 1100 to be programmed.

At programming of a conventional NAND flash memory, when first page data is received, it may be programmed as least significant bits of a super page. When second page data 55 is received, it may be programmed as central significant bits of the super page. At this time, the first page data programmed as the least significant bits may be read out from the NAND flash memory 1100, and a program operation may be performed using the read first page data and the input second 60 page data. When third page data is received, it may be programmed as most significant bits of the super page. At this time, the first and second page data programmed as the least significant bits and the central significant bits may be read out from the NAND flash memory 1100, and a program operation 65 may be performed using the read first and second page data and the input third page data.

10

With an embodiment of the inventive concept, when data (corresponding to a super page) required for program completion of memory cells connected with a word line of the NAND flash memory 1100 is accumulated at the phase change memory 1200, the accumulated data may be programmed at the NAND flash memory 1100. Thus, an operating speed of the memory system 1000 may be improved by skipping operations for reading data, programmed at least significant bits and central significant bits, from the NAND flash memory 1100. Also, a threshold voltage distribution of programmed memory cells may be improved by ending programming of memory cells connected with a word line at a time

FIG. 7 is a diagram illustrating an operating method in FIG. 2 executed in a memory system according to an embodiment of the inventive concept. It is assumed that a NAND flash memory 1100 has a program sequence described with reference to FIG. 5.

Referring to FIG. 7, a respectively represented by circle-1, circle-2 and circle-3, first to third pages of data PD1 to PD3 may be sequentially received from an external host. The first to third pages of data PD1 to PD3 may be accumulated at a phase change memory 1200. In example embodiments, the first to third pages of data PD1 to PD3 may correspond to a super page of a NAND flash memory 1100. That is, if the first to third pages of data PD1 to PD3 are accumulated at the phase change memory 1200, they may be programmed at the NAND flash memory 1100 as represent by circle-4 of FIG. 7.

FIG. 8 is a diagram illustrating an operating method in FIG. 2 executed in a memory system including a DRAM instead of a phase change memory according to an embodiment of the inventive concept. It is assumed that a NAND flash memory 1100 has a program sequence described with reference to FIG. 5.

Referring to FIG. **8**, a memory system **1000***a* may include a NAND flash memory **1100***a*, a DRAM **1200***a*, and a controller **1300***a*. As respectively represented by circle-1, circle-2 and circle-3, first to third pages of data PD1 to PD3 provided to the controller **1300***a* may be accumulated at the DRAM **1200***a*. If the first to third pages of data PD1 to PD3 accumulated at the DRAM **1200***a* correspond to a super page, they may be programmed at the NAND flash memory **1100***a* as represented by circle-4 of FIG. **8**.

The DRAM 1200a may be a volatile memory which loses data stored therein at power-off. That is, upon sudden power-off of the memory system 1000a, the first to third pages of data PD1 to PD3 accumulated at the DRAM 1200a may be lost. ("lost accumulated page when sudden power off" in FIG.8) That is, as represented by "x" and "X" in FIG. 8, it is impossible to transfer the first to third pages of data PD1 to PD3 accumulated at the DRAM 1200a into the NAND flash memory 1100. That is, a memory system 1000 including a phase change memory 1200 being a nonvolatile memory may be more reliable than the memory system 1000a including the DRAM 1200a being a volatile memory.

A device or algorithm for coping with the sudden poweroff can be provided to the memory system 1000a having the DRAM 1200a. However, such additional device or algorithm may cause an increase in complexity, cost, and power consumption of the memory system 1000a. Thus, compared with the memory system 1000a having the DRAM 1200a, the memory system 1000 including the phase change memory 1200 being a nonvolatile memory may reduce complexity, cost, and power consumption.

FIG. 9 is a diagram illustrating another example of an operating method in FIG. 2 executed in a memory system according to an embodiment of the inventive concept. Refer-

ring to FIG. 9, at circle-1 and circle-2, a first accumulated page of data APD1 at a phase change memory 1200 may be transferred and programmed at a NAND flash memory 1100. At circle-3 and circle-4, second accumulated page of data APD2 at the phase change memory 1200 may be transferred and programmed at the NAND flash memory 1100. At circle-5 and circle-6, third accumulated page of data APD3 at the phase change memory 1200 may be transferred and programmed at the NAND flash memory 1100.

In example embodiments, the first to third accumulated pages of data APD1 to APD3 may be successively received data. The phase change memory 1200 can be filled by the first to third accumulated pages of data APD1 to APD3.

Afterward, as represented by circle-7 of FIG. 9, the rest of data can be continuously received. Since the phase change memory 1200 is over-writable, the rest of data successively received may be overwritten at a storage area that data transferred to the NAND flash memory1100 was stored.

FIG. **10** is a diagram illustrating an operating method in 20 FIG. **2** executed in a memory system including a NAND flash memory instead of a phase change memory according to an embodiment of the inventive concept. Referring to FIG. **10**, a memory system **1000***b* may include NAND flash memories **1100***b* and **1200***b* and a controller **1300***b*.

At circle-1 and circle-2, first accumulated page of data APD1 at the NAND flash memory 1200b may be transferred and programmed at a NAND flash memory 1100b. At circle-3 and circle-4, second accumulated page of data APD2 at the NAND flash memory 1200b may be transferred and programmed at the NAND flash memory 1100b. At circle-5 and circle-6, third accumulated page of data APD3 at the NAND flash memory 1200b may be transferred and programmed at the NAND flash memory 1100b.

In example embodiments, the first to third accumulated 35 pages of data APD1 to APD3 may be successively received data. The NAND flash memory 1200b can be filled by the first to third accumulated pages of data APD1 to APD3.

Afterward, the remainder of the data can be continuously received as represented by circle-7 in FIG. 10. Howerver, as 40 respresented by the "X" and "Unoverwritable" in FIG. 10, the NAND flash memory 1200b may not be overwritten. That is, the NAND flash memory 1200b may have an erase-before-write characteristic. Thus, the NAND flash memory 1200b may be erased in advance to program the remainder of data 45 continuously received. This may cause a lowering of an operating speed of the memory system 1000b. In other words, since programming of the remainder of the data is not completed within a response time, an error may arise. A memory system 1000 having an over-writable phase change memory 50 1200 may exhibit improved operating speed and reliability compared with a memory system 1000b having a NAND flash memory not supporting an overwrite function.

A situation necessitating an erase operation may be prevented by increasing a capacity of the NAND flash memory 55 **1200***b*. However, this approach may cause an increase in an area of the memory system **1000***b* as well as an increase in a fabricating cost thereof. Thus, compared with a memory system **1000***b* having a NAND flash memory **1200***b* not supporting the overwrite function, the memory system **1000** having 60 the over-writable phase change memory **1200** may be advantageous to reduce an device area and a fabricating cost.

FIG. 11 is a diagram illustrating still another example of an operating method in FIG. 2 executed in a memory system according to an embodiment of the inventive concept. It is 65 assumed that a NAND flash memory 1100 has a program sequence described with reference to FIG. 5.

12

Referring to FIG. 11, at circle-1 data D1 to D5 may be accumulated at a phase change memory 1200. Each of data D1 to D5 may have a size smaller than a page. The data D1 to D5 may correspond to a super page. Since the data D1 to D5 corresponds to the super page, at circle-2 they may be programmed at a super page of the NAND flash memory 1100. For example, when one super page includes three pages, the data D1 to D5 may be dispersedly programmed at three pages.

FIG. **12**A is a diagram illustrating an operating method in FIG. **2** executed in a memory system having a NAND flash memory. Referring to FIG. **12**A, a memory system **1000**c may include a NAND flash memory **1100**c and a controller **1300**c.

The controller 1300c may program data received from an external device at the NAND flash memory 1100c. When data D1 is received, the controller 1100c at circle-1 of FIG. 12A may program the input data D1 at a page of the NAND flash memory 1100c.

When data D2 is received, the controller 1100c at circle-2 of FIG. 12A may program the input data D2 at the page, at which the data D1 is programmed, and a next page. When data D3 is received, the controller 1100c at circle-3 of FIG. 12A may program the input data D3 at the page, at which the data D2 is programmed. When data D4 is received, the controller 1100c at circle-4 of FIG. 12A may program the input data D4 at the page, at which the data D3 is programmed, and a next page. When data D5 is received, the controller 1100c at circle-5 of FIG. 12A may program the input data D5 at the page, at which the data D4 is programmed.

With embodiments of the inventive concept, a program operation may be executed after data D1 to D5 corresponding to a super page is received. Thus, a number of program (NOP) of each page may be '1'. However, as illustrated in FIG. 12A, if a phase change memory 1200 is not provided, a number of program (NOP) of each page may exceed '1'. In this case, data may be damaged due to program disturbance and the like. That is, with embodiments of the inventive concept, it is possible to prevent an error due to the number of program (NOP) from being generated.

FIG. 12B is a diagram illustrating another example of an operating method in FIG. 2 executed in a memory system having a NAND flash memory. Referring to FIG. 12B, a memory system 1000c may include a NAND flash memory 1100c and a controller 1300c.

The controller 1300c may program data received from an external device at the NAND flash memory 1100c. When data D1 is received, the controller 1100c at circle-1 of FIG. 12B may program the input data D1 at a page of the NAND flash memory 1100c. Afterwards, data D2 may be provided to the controller 1300c.

To reduce the number of program (NOP), no program operation may be performed with respect to a page experiencing a program operation. If the input data D1 is programmed at a page, data may not be programmed at the page. Thus, as represented by circle-2 of FIG. 12B, data D2 received after programming of the data D1 may be programmed at a page different from a page at which the data D1 is programmed. Likewise, as respectively represented by circle-3, circle-4 and circle-5 of FIG. 12B, data D3 to D5 may be programmed at different pages, respectively.

A size of each of data D1 to D5 may be smaller than that of a page. Thus, pages programmed with the data D1 to D5 may have free spaces, respectively. No data may be programmed at the free spaces of the pages. That is, if a phase change memory 1200 according to an embodiment of the inventive concept is not provided, the above-described free spaces of the NAND

flash memory 1100c may increase, thus lowering the operating efficiency of the NAND flash memory 1100c and the memory system 1000c.

According to an embodiment of the inventive concept, data not corresponding to a super page, for example, data smaller 5 in size than the super page may be accumulated at the phase change memory 1200. When the accumulated data corresponds to the super page, it may be programmed at the NAND flash memory 1100c. Thus, it is possible to prevent inefficiency due to limit of the number of program (NOP) of the 10 NAND flash memory 1100c.

FIG. 13 is a flowchart illustrating an operating method of a memory system according to another embodiment of the inventive concept. Referring to FIGS. 1 and 13, in operation S210, data to be programmed may be received. In operation 15 S220, page data may be programmed at a phase change memory 1200.

In operation S230, whether a free capacity of the phase change memory 1200 reaches a threshold value may be judged. For example, the controller 1300 may judge whether 20 a free capacity of the phase change memory 1200 reaches a threshold value. The threshold value may be set to 5%, 10%, 15%, 20%, or the like of the entire capacity of the phase change memory 1200. When the free capacity of the phase change memory 1200 is judged to reach a threshold value, the 25 method proceeds to operation S240. If not, the method returns to operation S210.

In operation S240, data, corresponding to a super page, from among data accumulated at the phase change memory 1200 may be programmed at a NAND flash memory 1100. 30 For example, data, corresponding to one or more super pages, from among accumulated at the phase change memory 1200 may be programmed at the NAND flash memory 1100. All accumulated data, corresponding to a super page, from among data accumulated at the phase change memory 1200 35 can be programmed at the NAND flash memory 1100.

FIG. 14 is a diagram of the phase change memory 1200 to further describe the operating method shown in FIG. 13 executed in a memory system according to embodiments of the inventive concept. In FIG. 14, the encircled numbers 1~10 40 denote a sequence of page programming and page output operations of the phase change memory 1200. Referring to FIGS. 1, 13, and 14, pages of data APD1 to APD4 may be accumulated at a phase change memory 1200. Data stored at a memory system 1000 may be updated by an external host. 45 Upon updating of data stored at a NAND flash memory 1100 having an erase-before-write characteristic, there may be required operations of reading data to be updated, updating the read data, programming the updated data, and erasing an area from which data to be updated is read. On the other hand, 50 accumulated data APD1 and APD3 stored at the phase change memory 1200 being over-writable may be updated with new accumulated data APD1' and APD3' through an overwrite operation. Afterwards, the accumulated data APD1' and APD3' updated at the phase change memory 1200 may be 55 programmed at the NAND flash memory 1100.

According to an embodiment of the inventive concept, page data may be accumulated at the phase change memory 1200 until a free capacity of the phase change memory 1200 reaches a threshold value. Thus, overhead may be reduced 60 upon data updating of the memory system 1000.

In example embodiments, when page data accumulated at the phase change memory 1200 satisfies a threshold condition, it may be transferred to the NAND flash memory 1100 to be programmed. However, the inventive concept is not limited thereto. For example, when page data accumulated at the phase change memory 1200 and page data transferred to the

14

controller 1300 from an external host satisfy a threshold condition, they may be transferred to the NAND flash memory 1100 to be programmed.

FIG. 15 is a block diagram schematically illustrating a phase change memory according to an embodiment of the inventive concept. Referring to FIG. 15, a phase change memory 1200 may include a memory cell array 1210, an address decoder 1220, a bit line selection circuit 1230, a write driver 1240, a sense amplifier 1250, a data input/output circuit 1260, and control logic 1270.

The memory cell array 1210 may be connected to the address decoder 1220 via word lines WL and to the bit line selection circuit 1230 via bit lines BL. The memory cell array 1210 may include a plurality of memory cells. In example embodiments, memory cells arranged in a row direction may be connected to the word lines WL, and memory cells arranged in a column direction may be connected to the bit lines BL. In example embodiments, each of the memory cells of the memory cell array 1210 may store one or more bits of data

The address decoder 1220 may be connected to the memory cell array 1210 via the word lines WL. The address decoder 1220 may be configured to operate responsive to the control of the control logic 1270. The address decoder 1220 may receive an address ADDR from an external device.

The address decoder 1220 may be configured to decode a row address of the input address ADDR. Using the decoded row address, the address decoder 1220 may select the word lines WL. The address decoder 1220 may be configured to decode a column address of the input address ADDR. The decoded column address DCA may be provided to the bit line selection circuit 1230. In example embodiments, the address decoder 1220 may include constituent elements such as a row decoder, a column decoder, an address buffer, and the like.

The bit line selection circuit 1230 may be connected to the memory cell array 1210 through the bit lines BL and to the write driver 1240 and the sense amplifier 1250. The bit line selection circuit 1230 may operate responsive to the control of the control logic 1270. The bit line selection circuit 1230 may be configured to receive the decoded column address DCA from the address decoder 1220. Using the decoded column address DCA, the bit line selection circuit 1230 may select the bit lines BL.

At a program operation, the bit line selection circuit 1230 may connect the bit lines BL to the write driver 1240. At a read operation, the bit line selection circuit 1230 may connect the bit lines BL to the sense amplifier 1250.

The write driver 1240 may operate responsive to the control of the control logic 1270. The write driver 1240 may be configured to program memory cells defined by bit lines selected by the bit line selection circuit 1230 and a word line selected by the address decoder 1220. The write driver 1240 may generate a set current or a reset current according to data received from the data input/output circuit, and may output the set current or the reset current to the selected bit lines. The set current and reset current are described later with reference to FIGS. 16 and 17.

The sense amplifier 1250 may operate responsive to the control of the control logic 1270. The sense amplifier 1250 may be configured to read memory cells defined by bit lines selected by the bit line selection circuit 1230 and a word line selected by the address decoder 1220. The sense amplifier 1250 may read the memory cells by sensing currents flowing through the selected bit lines or voltages of the selected bit lines. The sense amplifier 1250 may output the read data to the data input/output circuit 1260.

The data input/output circuit 1260 may operate responsive to the control of the control logic 1270. The data input/output circuit 1260 may transfer externally received data to the write driver 1240 and output data provided from the sense amplifier 1250 to an external device.

The control logic 1270 may control an overall operation of the phase change memory 1200. The control logic 1270 may operate responsive to a command CMD and a control signal CTRL received from the external device.

The phase change memory 1200 may provide random 10 access functionality. A physical address system of the phase change memory 1200 may be equal to a logical address system of an external host. Thus, a controller 1300 in FIG. 1 may not necessitate a device for translating a logical address of the external host into a physical address of the phase change 15 memory 1200.

FIG. 16 is a diagram illustrating a memory cell of a phase change memory. Referring to FIG. 16, a memory cell MC may include a resistance variable element GST and a selection element. In this example, the selection element is a selection transistor MT. Also in this example, the resistance variable element GST may be connected to a bit line BL, and the selection transistor MT may be connected between the resistance variable element GST and a ground. Here, a gate of the selection transistor MT may be connected to a word line WL. 25

If a voltage is applied to the word line WL, the selection transistor MT may be turned on. At this time, the resistance variable element GST may be supplied with a current via the bit line BL.

The resistance variable element GST may include a phase 30 change material. The phase change material may include a Ge—Sb—Te (GST) material whose resistance varies according to a temperature. The phase change material may have one of two states, that is, a crystal state and an amorphous state. The phase change material may be switched into a crystal 35 state or an amorphous state according to a current supplied via the bit line BL, whereby the current results in Joule heating to thermally transition the state of the phase change material.

FIG. 17 is a graph illustrating temperature (TMP(° C.)) versus time (T(sec)) characteristics of a phase change material during programming of the phase change material. In FIG. 17, a reference numeral 1 may indicate such a temperature condition that a phase change material is transitioned to an amorphous state, and a reference numeral 2 may indicate such a temperature condition that a phase change material is 45 transitioned a crystal state.

Referring to FIGS. **16** and **17**, a phase change material may be set to the amorphous state when it is heated at a temperature higher than a melting temperature Tm during a first time T1 and then is quickly quenching. The amorphous state may 50 be referred to as a reset state, and may represent stored data of logic '1'.

The phase change material may be set to the crystal state when it is heated at a temperature lower than a melting temperature Tm and higher than a crystallization temperature Tc 55 during a second time T2 which is longer than the first time T1, and followed by relatively slow quenching. The crystal state may be referred to as a set state, and may represent stored data of logic '0'.

The memory cell MC may have a resistance varies with a 60 change in an amorphous volume of a phase change material. That is, the resistance of the memory cell MC may larger than that of the amorphous state (reset state) and smaller than that of the crystal state (set state).

FIG. 18 is a block diagram schematically illustrating a 65 memory system according to another embodiment of the inventive concept. Referring to FIG. 18, a memory system

16

2000 may include a NAND flash memory 2100, a phase change memory 2200, and a controller 2300. Compared with the memory system 1000 shown in FIG. 1, the phase change memory 2200 may include an on-chip error correcting code (ECC) block 2210, and the controller 2300 may include a NAND ECC block 2310.

In example embodiments, the on-chip ECC block 2210 may use a hamming code. The NAND ECC block 2310 a BCH (Bose-Chadhuri-Hocquenghem) code, an RS (Reed-Solomon) code, a turbo code, an LDPC (Low Density Parity Check) code, and the like.

When data is stored at the phase change memory 2200, the controller 2300 may not use the NAND ECC block 2310. The phase change memory 2200 may generate parity data Parity_P using the on-chip ECC block 2210. That is, data stored at the phase change memory 2200 may include user data and parity data Parity_P generated by the on-chip ECC block 2210.

When data is transferred to the NAND flash memory 2100 from the phase change memory 2200, the phase change memory 2200 may remove the parity data Parity_P using the on-chip ECC block 2210. The controller 2300 may generate parity data Parity_N using the NAND ECC block 2310. That is, data stored at the NAND flash memory 2100 may include user data and the parity data Parity_N generated by the NAND ECC block 2310.

When data is read from the NAND flash memory 2100, the controller 2300 may remove the parity data Parity_N using the NAND ECC block 2310.

FIG. 19 is a block diagram schematically illustrating a memory system according to still another embodiment of the inventive concept. Referring to FIG. 19, a memory system 3000 may include a NAND flash memory 3100, a phase change memory 3200, and a controller 3300. Compared with the memory system 1000 shown in FIG. 1, the phase change memory 3200 may include an on-chip error correcting code (ECC) block 3210, and the controller 3300 may include a NAND ECC block 3310.

When data is stored at the phase change memory 3200, the controller 3300 may generate parity data using the NAND ECC block 3310. The phase change memory 3200 may generate parity data Parity_P using the on-chip ECC block 3210. That is, data stored at the phase change memory 3200 may include user data, parity data Parity_N generated by the NAND ECC block 3310, and parity data Parity_P generated by the on-chip ECC block 3210.

When data is transferred to the NAND flash memory 3100 from the phase change memory 3200, the phase change memory 3200 may remove the parity data Parity_P using the on-chip ECC block 3210. The controller 3300 may not use the NAND ECC block 3310. That is, data stored at the NAND flash memory 3100 may include user data and the parity data Parity_N generated by the NAND ECC block 3310.

When data is read from the NAND flash memory 3100, the controller 3300 may remove the parity data Parity_N using the NAND ECC block 3310.

FIG. 20 is a block diagram schematically illustrating a memory system according to still another embodiment of the inventive concept. Referring to FIG. 20, a memory system 4000 may include a NAND flash memory 4100, a phase change memory 4200, and a controller 4300. Compared with a memory system 1000 in FIG. 1, the controller 4300 may control the NAND flash memory 4100 and the phase change memory 4200 via a common bus. The NAND flash memory 4100 and the phase change memory 4200 may communicate with the controller 4300 using time division techniques.

Data accumulated at the phase change memory 4200 may be directly transferred to the NAND flash memory 4100 via the common bus without passing through the controller 4300.

FIG. 21 is a block diagram schematically illustrating a memory system according to still another embodiment of the inventive concept. Referring to FIG. 21, a memory system 5000 may include a NAND flash memory 5100, a phase change memory 5200, and a controller 5300. Compared with the memory system 1000 shown in FIG. 1, the NAND flash memory 5100 may communicate with the controller 5300 via a plurality of channels CH1 to CHk. Each channel may be connected with a plurality of NAND flash memory chips.

In example embodiments, as described with reference to FIG. 20, the NAND flash memory 5100 and the controller 5300 may be connected via a common bus, and the plurality of channels CH1 to CHk may occupy the common bus using time division techniques.

In example embodiments, as described with reference to FIG. 20, the NAND flash memory 5100 and the phase change 20 memory 5200 may be connected with the controller 5300 via a common bus, and may communicate with the controller 5300 using time division techniques.

FIG. 22 is a block diagram schematically illustrating a memory system according to still another embodiment of the 25 inventive concept. Referring to FIG. 21, a memory system 6000 may include a NAND flash memory 6100, a phase change memory 6200, and a controller 6300. Compared with the memory system 1000 shown in FIG. 1, the NAND flash memory 6100 may communicate with the controller 5300 via 30 a plurality of channels CH1 to CHk. Each channel may be connected with a plurality of NAND flash memory chips. The phase change memory 6200 may communicate with the controller 6300 via the plurality of channels CH1 to CHk. A phase change memory chip may be connected to each chan- 35

A phase change memory connected with each channel may correspond to a plurality of NAND flash memory chips connected with a channel. Data to be programmed at NAND flash memory chips connected with one channel may be pro- 40 grammed at a phase change memory chip connected with a corresponding channel.

In example embodiments, as described with reference to FIG. 20, the NAND flash memory 6100 and the controller 6300 may be connected via a common bus, and the plurality 45 comprising: of channels CH1 to CHk may occupy the common bus using time division techniques.

In example embodiments, as described with reference to FIG. 20, the NAND flash memory 6100 and the phase change memory 6200 may be connected with the controller 6300 via 50 a common bus, and may communicate with the controller 6300 using time division techniques.

FIG. 23 is a diagram illustrating a memory card according to an embodiment of the inventive concept. Referring to FIG. 23, a memory card 7000 may include a NAND flash memory 55 7100, a phase change memory 7200, a controller 7300, and a

The controller 7300 may accumulate data at the phase change memory 7200. When data accumulated at the phase change memory 7200 corresponds to a super page, the controller 7300 may program the accumulated data in the NAND flash memory 7100.

The memory card 7000 may be formed of memory cards such as a PC (PCMCIA) card, a CF card, an SM (or, SMC) card, a memory stick, a multimedia card (MMC, RS-MMC, 65 MMCmicro), a security card (SD, miniSD, microSD, SDHC), a universal flash storage (UFS) device, and the like.

18

FIG. 24 is a diagram illustrating a solid state drive according to an embodiment of the inventive concept. Referring to FIG. 24, a solid state drive 8000 may include a plurality of NAND flash memory 8100, a phase change memory 8200, a controller 8300, and a connector 8400.

The controller 8300 may accumulate data at the phase change memory 8200. When data accumulated at the phase change memory 8200 corresponds to a super page, the controller 8300 may program the accumulated data in the NAND flash memory 8100.

FIG. 25 is a block diagram illustrating a computing system according to an embodiment of the inventive concept. Referring to FIG. 25, a computing system 9000 may include a central processing unit 9100, a RAM 9200, a user interface 9300, a modem 9400, a system bus 9500, and a memory system 9600.

The memory system 9600 may be connected electrically with the elements 9100 to 9400 via the system bus 8500. Data provided via the user interface 9300 or processed by the central processing unit 9100 may be stored in the memory system 9600.

The memory system 9600 may be one of memory systems 1000 to 6000 described with reference to FIGS. 1 and 18 to

An embodiment of the inventive concept is described with respect to memory systems which include a phase change memory and a NAND flash memory. However, as previously mentioned, the inventive concept is not limited thereto. The inventive concept may be applied to a memory system including a NAND flash memory and other types of variable resistance memories such as MRAM, FeRAM, ReRAM, and the like. The resistance-variable memory may comply with a NAND sequence.

While the inventive concept has been described with reference to exemplary embodiments, it will be apparent to those skilled in the art that various changes and modifications may be made without departing from the spirit and scope of the present invention. Therefore, it should be understood that the above embodiments are not limiting, but illustrative.

What is claimed is:

1. An operating method of a memory system, the memory system including a NAND flash memory, a resistance variable memory, and a controller controlling the NAND flash memory and the resistance variable memory, the method

receiving data;

programming the received data in the NAND flash memory when the received data is at least a super page of data; programming the received data in the resistance variable memory when the received data is not the super page of data; and

programming data accumulated in the resistance variable memory in the NAND flash memory when the data accumulated in the resistance variable memory is the super page of data,

wherein the super page of data is an entirety of data that is programmable in memory cells connected to a same word line of the NAND flash memory.

- 2. The operating method of claim 1, wherein two or more bits of data are programmable in each of the memory cells connected to the same word line of the NAND flash memory, and wherein the super page of data includes two or more bits being programmed at each of the memory cells connected to the same word line.
- 3. The operating method of claim 2, wherein the NAND flash memory includes adjacent memory cells connect to a word line adjacent the same word line, and wherein the super

19

page of data further includes at least one bit being programmed at each of the adjacent memory cells.

- 4. The operating method of claim 3, wherein a program operation is performed in sequence with respect to the same word line and the adjacent word line; and wherein the super page of data further comprises first data being programmed at the memory cells connected to the same word line and second data being programmed at the adjacent memory cells connected to the adjacent word line, the first and second data being required until programming of the memory cells connected to the same word line is completed.
- 5. The operating method of claim 1, wherein the programming the received data in the resistance variable memory comprises:
 - generating first data by adding a first parity to the received data; and
 - programming the first data at the resistance variable memory, the generating and the programming being performed by the controller.
- 6. The operating method of claim 5, wherein the programming the first data in the resistance variable memory comprises:
 - generating second data by adding a second parity to the first data; and
 - programming the second data, the generating and the programming the second data being performed by the resistance variable memory.
- 7. The operating method of claim **6**, wherein the programming the accumulated data in the NAND flash memory comprises:
 - removing the second parity from accumulated data of the second data; and
 - programming the data, from which the second parity is removed, in the NAND flash memory, the removing of the second parity being performed by the resistance variable memory.
- 8. The operating method of claim 1, wherein the programming the received data in the NAND flash memory comprises:
 - generating third data by adding a second parity to the received data; and
 - programming the third data, the generating and the programming being performed by the resistance variable memory.
- 9. The operating method of claim 8, wherein the programming the accumulated data in the NAND flash memory comprises:
 - removing the second parity from accumulated data of the third data being performed by the resistance variable 50 memory;
 - adding a first parity to the data, from which the second parity is removed by the controller; and
 - programming the first parity-added data in the NAND flash memory.
- 10. The operating method of claim 1, wherein the resistance variable memory is a phase change memory.
- 11. The operating method of claim 1, wherein the resistance variable memory has over-write functionality.
- 12. The operating method of claim 1, wherein physical and $\,^{60}$ logical address systems of the resistance variable memory are the same.

20

- 13. The operating method of claim 1, wherein the resistance variable memory and the NAND flash memory communicate with the controller via a common bus.
- 14. The operating method of claim 1, wherein the resistance variable memory supports a plurality of numbers of program with respect to memory cells of the resistance variable memory connected to a word line.
- 15. An operating method of a memory system which includes a NAND flash memory, a resistance variable memory, and a controller controlling the NAND flash memory and the resistance variable memory, where the NAND flash memory is configured to store N bits of data per memory cell, and N pages of data per word line of each memory block, and where N is two or more, the method comprising:

receiving data;

- programming the received data in the NAND flash memory when the received data is at least N pages of data;
- programming the received data in the resistance variable memory when the received data is less than N pages of data; and
- programming accumulated data programmed in the resistance variable memory in the NAND flash memory when the accumulated data is at least N pages of data.
- 16. The operating method of claim 15, wherein the resistance variable memory is a random access memory having over-write functionality.
- 17. The operating method of claim 15, wherein the resistance variable memory is a phase change random access memory (PRAM).
- **18**. The operating method of claim **15**, wherein the programming the input data in the resistance variable memory comprises:
 - generating first data by adding a first parity to the input data; and
 - programming the first data in the resistance variable memory, the generating and the programming being performed by the controller.
- 19. The operating method of claim 18, wherein the programming the first data in the resistance variable memory comprises:
 - generating second data by adding a second parity to the first data; and
 - programming the second data, the generating and the programming the second data being performed by the resistance variable memory.
 - 20. An operating method of a memory system which includes a NAND flash memory, a resistance variable memory, and a controller controlling the NAND flash memory and the resistance variable memory, the method comprising:

receiving data;

- programming the received data in the resistance variable memory; and
- programming a super page of data among data accumulated in the resistance variable memory in NAND flash memory when a free capacity of the resistance variable memory reaches a threshold value,
- wherein the super page of data is an entirety of data that is programmable in memory cells of the NAND flash memory connected to a same word line of the NAND flash memory.

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